

Attorney Docket No. 0756-2424

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:					
Osamu NAKAMURA et al.					
Serial No. 10/046,893					
Filed: January 17, 2002					
For: METHOD OF MANUFACTURING					

SEMICONDUCTOR DEVICE

P.O. Box 1450, Alexandria, VA 22313-1450, on 10.31.03

CERTIFICATE OF MAILING
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Group Art Unit: 2823

Examiner: H. Lee

## INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The references cited on PTO 1449 Form, Page 1 (List 1), are all patents of the Assignee (Semiconductor Energy Laboratory Co., Ltd.), which may relate to the subject application.

The references cited on PTO 1449 Form, Pages 1-4 (List 2), are references which were cited in U.S. Serial No. 10/056,055. U.S. Serial No. 10/056,055 corresponds to U.S. Patent Publication No. 2002/0134981 (List 1)

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be 11/04/2003 SSANDARA 00000006 10046893

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required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,

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Substitute for form 1449A/PTO  INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				C	omplete if Known		
			TOSHDE	Application Number	10/046,893	$\sim$	PE ve
				Filing Date	January 17, 2002	70	3
				First Named Inventor	Osamu Nakamura et al.		3 1 2003 2
			ssary)	Group Art Unit	2823	OC	3 , 2
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Sheet	l (List l)	of	1	Attorney Docket Number	0756-2424	*TEN	& TRADEMART

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			·F(	OREIGN PATENT DOCU	MENTS		
Cite Foreign Patent Document		de <sup>5</sup>	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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		OTHER P	RIOR	ART - NON PATENT LITER	LATURE DOCUMENTS		
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е.	' ├-	Office <sup>3</sup> Nu	Office' Number' (if know	Foreign Patent Document    Foreign Patent Document	FOREIGN PATENT DOCU  Foreign Patent Document  Name of Patentee or Applicant of Cited Document  Office Number (if known)  OTHER PRIOR ART - NON PATENT LITER  Include name of the author (in CAPITAL LETTERS), ti item (book, magazine, journal, serial, symposium, catalogous)	FOREIGN PATENT DOCUMENTS  Foreign Patent Document  Name of Patentee or Applicant of Cited Document  Number (if known)  OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS  Include name of the author (in CAPITAL LETTERS), title of the article (when appropr	FOREIGN PATENT DOCUMENTS    Foreign Patent Document

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Signature	Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached. 
<sup>1</sup> Unique citation designation number. <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449A/PTO				C	omplete if Known	ر ا	
INFO	DM ATION I	)ISC	LOSUDE	Application Number	10/046,893	/b	IPE
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	(use as many sheets	as necess	ary)	Group Art Unit	2823	C	ري 3 1 2003
				Examiner Name	H. Lee	瓷	<i>\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\</i>
Sheet	1 (List 2)	of	4	Attorney Docket Number	0756-2424	No.	PRADEMARK

		U.S. Patent Document	[	Date of Publication of Cited	Pages, Columns, Lines, Where Relevan
Examiner Initials	Cite No. <sup>1</sup>		Name of Patentee or Applicant of Cited Document	Document MM-DD-YYYY	Passages or Relevant Figures Appear
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Substitute	for form 1449A/PTO		V	TRADEMA	Complete if Known
INFO	RMATION I	) I C C I	ACTION	Application Number	10/046,893
				Filing Date	January 17, 2002
STATEMENT BY APPLICANT (use as many sheets as necessary)				First Named Inventor	Osamu NAKAMURA et al.
				Group Art Unit	2823
				Examiner Name	H. Lee
Sheet	2 (List 2)	of	4	Attorney Docket Number	0756-2424

		U.S. Patent Document	U.S. PATENT DOCUMENT	Date of Publication of Cited	Pages, Columns, Lines, Where Relevan
Examiner Initials	Cite No. <sup>1</sup>	Number Kind Code <sup>2</sup>	Name of Patentee or Applicant of Cited Document	Document MM-DD-YYYY	Passages or Relevant Figures Appear
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3 (List 2)

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number	10/046,893
Filing Date	January 17, 2002
First Named Inventor	Osamu NAKAMURA et al.
Group Art Unit	2823
Examiner Name	H. Lee
Attorney Docket Number	0756-2424

				U.S. PATENT DOCUMEN	TS	
Examiner Initials	Cite No.¹	U.S. Patent Docur	nent ind Code <sup>2</sup>	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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				Examiner Name	H. Lee
Sheet	4 (List 2)	of	4	Attorney Docket Number	0756-2424

	<del></del>			FOREIGN PATENT DOC	UMENTS					
Examiner Initials	Cite No.	Office <sup>3</sup>	Foreign Patent Document  Kind Code <sup>5</sup> Number <sup>4</sup> (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	τ*			
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			OTHER PRIC	OR ART – NON PATENT LITE	RATURE DOCUMENTS					
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Examiner	 Date	
Signature	 Considered	

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